

Docket No.: 474082001100
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Akira HORIGUCHI et al.

Application No.: 09/743,502

Confirmation No.: 4060

Filed: June 7, 2001

Art Unit: 3723

For: DOUBLE SIDE POLISHING METHOD AND
APPARATUS

Examiner: E. P. Morgan

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

In response to the Action mailed January 30, 2009, Applicants elect the claims of Group I, claims 1, 2, 5, 6, 15-17, 20-23, 27 and 28, for prosecution at this time, *without traverse*.

In the event that the transmittal form is separated from this document and the Patent Office determines that an extension and/or other relief is required, Applicant petitions for any required relief including extensions of time and authorize the Commissioner to charge the cost of such petitions and/or other fees due in connection with the filing of this document to **Deposit Account No. 03-1952** referencing **474082001100**.

Dated: February 27, 2009

Respectfully submitted,

By 

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